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Class	ISSUE C
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U.S. UTILITY Patent Application

CLASS	7D4
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PATENT DATE

APPLICATION NO.	09/682151	CONT/PRIOR	CLASS	257	SUBCLASS	758	ART UNIT	810	EXAMINER	Chen
APPLICANTS		BEST AVAILABLE COPY								
TITLE		Contact method for thin silicon carbide epitaxial layer and semiconductor devices formed by those methods								

PTO-2040
(12/89)

CLASSIFICATION